

Electronic Acknowledgement Receipt

EFS ID:	1104702
Application Number:	10672085
Confirmation Number:	7062
Title of Invention:	Methods and apparatus for optimizing the delivery of a set of gases in a plasma processing system
First Named Inventor:	Fangli Hao
Customer Number:	32986
Filer:	Joseph A. Nguyen
Filer Authorized By:	
Attorney Docket Number:	LMRX-P026/P1068
Receipt Date:	06-JUL-2006
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Application Type:	Utility
International Application Number:	

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		LMRX-P026AA-US-2006070 6-TP-amdt_A_for_filing.pdf	139198	yes	8

	Multipart Description		
	Doc Desc	Start	End
	Transmittal letter	1	1
	Amendment - After Non-Final Rejection	2	8

Warnings:

Information:

Total Files Size (in bytes):	139198
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.